

LEWA Micro- metering pumps

with diaphragm technology for
laboratories, test centers and production.







LEWA offers a comprehensive line of micro-metering pumps with diaphragm technology for metering fluids in laboratories and test centers.

This includes solenoid-driven diaphragm metering pumps covering an extensive range of applications with four different solenoid power sizes. The motorized FC micro-metering pumps put the finishing touch on our portfolio. All of the models are capable of a wide variety of tasks. Development of this product line is driven by close collaboration with users.

LEWA diaphragm pumps for the smallest metered flows. The advantages at a glance.

1



High pressure levels

The micro-metering pumps can be used at pressure levels up to 8,120 psig. This is made possible by the hydraulic actuation of the diaphragm pump heads.

2



Leak-proof and reliable

The pump is hermetically sealed by the diaphragm's static seal, making it incredibly reliable. The metal diaphragm is absolutely impervious to leaks caused by diffusion, completely eliminating the chance of leaks from pumped fluid or hydraulic oil.

3



Precise

Drive units free of backlash with a precise stroke length setting, optimized valves and hydraulically actuated metal diaphragms ensure maximum metering accuracy.

4



Reliable

The pumps are designed for continuous operation. Hydraulic actuation allows our metal diaphragms to achieve an outstanding service life. The same applies to the displacement pistons running under optimal lubricating conditions in the hydraulic oil.

5



Resistant materials

All parts in contact with fluid are made of high-quality stainless steel or nickel alloys. This ensures the best resistance to all fluids used in laboratory settings and a long service life.

6



Global service

LEWA is a global company. Spare parts and service are quickly available throughout the world.

Application examples in laboratories and test centers.



Oil and gas industry

Metering corrosion inhibitors and anti-foaming agents



Gas odorization

Metering mercaptan or THT for adding an odor to gas



Refineries

Metering DMDS for fuel reforming



Chemical industry

Metering for high-pressure hydrogenation, high-pressure synthesis and polymerization



Plastics

Metering of binders and peroxides



Petrochemicals

Metering of conductivity enhancers



Personal care

Metering of fragrances in creme production



Pharmaceuticals and biotechnology

Metering of buffer solutions for chromatography



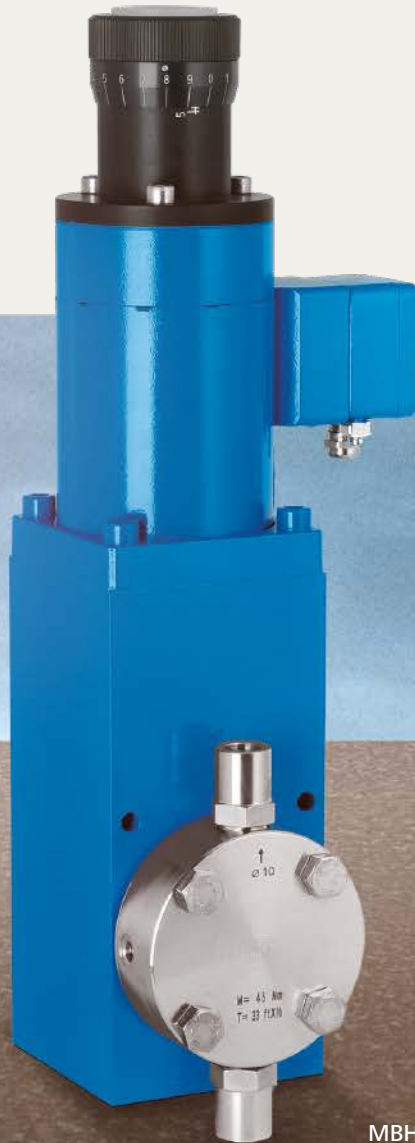
Energy utilities

Metering of oxygen binders

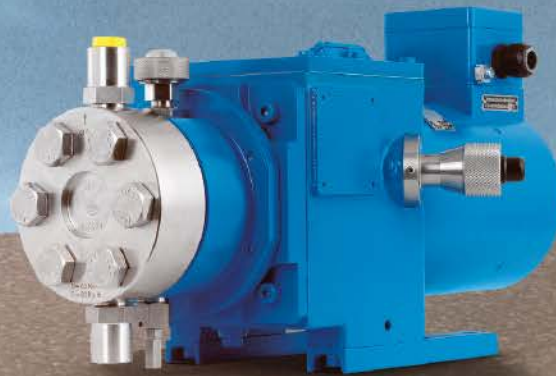
LEWA micro-metering pumps with solenoid actuator.

LEWA solenoid-driven diaphragm metering pumps from the MAH/MBH and MLM series cover a comprehensive range of applications with four different solenoid power sizes.

Control systems specifically developed for this line permit adaptation to a wide variety of different tasks. They are installed in test center systems or laboratory rigs. Integration into higher-level process control systems is easy to implement.



MBH series



MLM series



MAH series

Performance data

	MAH/MBH series	MLM series
Discharge pressure	15 to 725 psig	15 to 8,120 psig
Flow rate	0 to 0.66 gph	0 to 14.53 gph

Advantages

Maximum metering accuracy (at constant basic conditions: +/- 1%)

Extremely wide control range up to 1:1000 for maximum metering flexibility

Unique, high-performance stroke solenoids tried and tested for more than 30 years

Simple operation

Absolutely odor-tight and free of leaks

Absolutely dry-run safe for maximum process safety

Ideal for clean, hazardous, toxic and viscous (max. 50 cp) fluids

Metering flow setting from 0 to the maximum using two control variables:

– Using the stroke length with finely scaled handwheel

– MAH/MBH and MLM series: Using the stroke frequency by means of a control system set up separately (MSG)

Compliance with typical standards such as DVGW G280

Maximum reliability and availability even after operating errors or in extreme operating states (such as high inlet pressure, closed discharge or suction line)

Low-maintenance and low-wear (we recommend routine maintenance 1x per year)

Minimum life cycle costs thanks to high energy efficiency, low maintenance costs and extremely long service life of diaphragm and process valves

Additional advantages of the MAH/MBH series:

Precision valves made of ceramics and ruby for outstanding leak tightness and wear resistance

Pump heads can be heated and cooled

Pump heads can be sterilized

Easy to put into operation thanks to self-venting hydraulic system

Low-noise operation thanks to integrated damping system

Options:

- Complementary control systems (MSG) for Ex or non-Ex zone
- Complementary flow meters available
- Sandwich diaphragm with diaphragm monitoring (only MLM)
- Special valves, e.g. oxide-ceramics for valve seat and ball
- Special materials, such as Hastelloy



MSG control system for micro-metering pumps with solenoid actuator.



MSG solenoid-driven pump control system

Inexpensive solution specifically developed for the MAH/MBH and MLM series

Can be used as internal and external control system:

- The drive solenoid is controlled by the integrated stroke frequency generator with linear setting characteristic curve
- An external standard analog signal from 0 or 4 to 20 mA is used for control
- Passive external pulses are used for control

Stroke length setting with linear characteristic curve enables customized optimization of stroke volume and stroke frequency

The external inputs enable integration of the pumps into higher-level control loops or proportional coupling with external reference variables. The stroke length setting is then used as an additional ratio setter

Optionally for switch panel-mounting, workbench housing or as plug-in unit for 19" installation frame

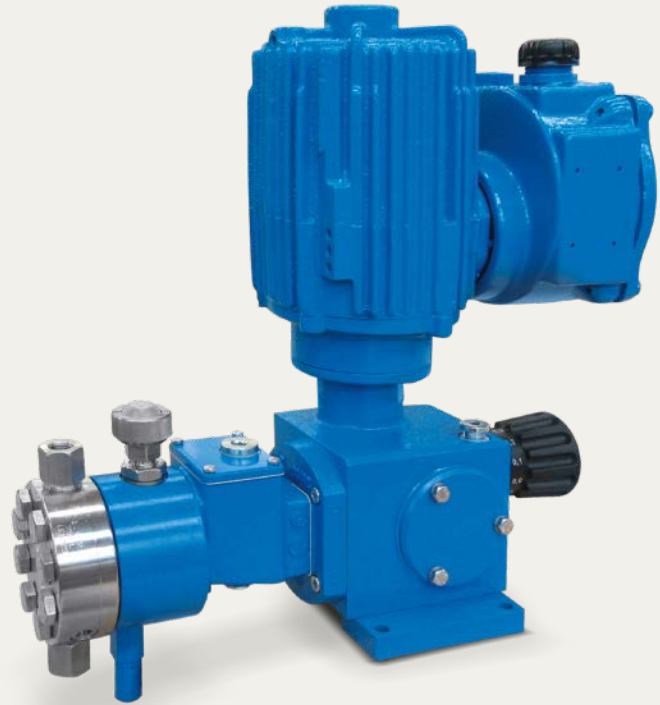
LEWA FC micro-metering pumps.

The FC micro-metering pump was developed specifically for laboratories and test centers.

The motorized pump meets the highest demands for accuracy, reproducibility, cleanliness and adjustment range. Multiple pump heads and drives can also be combined as desired to form multiplex pumps.

FC series performance data

Discharge pressure	Piston pump head: max. 2,320 psig
	Diaphragm pump head: max. 5,800 psig
Flow rate	Piston pump head: 0 to 17.17 gph
	Diaphragm pump head: 0 to 0.40 gph



Advantages

High metering accuracy of +/- 1%

Beneficial drive unit kinematics (cam and spring drive) for the smallest metered flows

Wider adjustment range with consistently high efficiency and rigid compression curve

Control system and monitoring electronics tuned to the respective application

Accurately operating drive units with an electric drive and a plunger spring return that is friction-locking and absolutely free of play

Oil lubrication of all moving parts, with protection from severe weather and splash water

Low-noise, ideal for laboratory work

Can be sterilized

Pressure relief valve integrated into the diaphragm design

Superior metal diaphragm technology, hermetically sealed and resistant to excess pressure

Dry-run safe and featuring diaphragm design free of dynamic seals



Pump heads

Type	Pressure	Flow rate	Temperature	Viscosity
M213	5,800 psig	0 - 0.40 gph	-22.0/+248.0 °F	50 mPa·s
K110	2,320 psig	0 - 17.17 gph	-94.0/+752.0 °F	1,000 mPa·s

Options:

Available with piston or diaphragm design

Multiplex capability

As a single drive unit or multiplex drive unit with space-saving vertically attached motor

Multiplex drive units with identical output can be combined
(for pulsation reduction or recipe metering, for example)

Ex-protected design

Heating/cooling jacket

Special coatings

Complete control system/regulation product line, suitable for PLC integration

Assortment of material and valve variants

Electrical and pneumatic stroke adjustment

Comprehensive documentation, testing protocols, pressure samples, pump diagrams
and approvals

Accessories and technical data.

Accessories for micro-metering pumps

- Filter with gas trap
 - Ideal for metered flows of up to 0.53 gph
 - Separates out suction-side contaminants and gas
- Pressure retaining valves with startup venting (for MAH/MBH)
 - Prevents excessive pumping
 - Enables venting of the pump head during startup
 - Required if the operating pressure is 15 psig above the suction pressure
- KMM1 micro flow meter for measuring flow rate

MAH, MAH Ex, MBH Ex technical data

Pump type		MAH 3	MAH 3 Ex	MAH 4	MAH 4 Ex	MAH 5	MAH 5 Ex	MAH 8	MAH 8 Ex	MBH 8 Ex	MBH 10 Ex
Metered flow	Q [gph]	0 to 0.05		0 to 0.07		0 to 0.16		0 to 0.42		0 to 0.45	0 to 0.63
Operating pressure	p_o min [psig]	15		15		15		15		15	15
	p_o max [psig]	725	435	363	232	232	145	87	58	725	580
Intake pressure	p_s min [psig abs.]	15		15		15		15		15	15
	p_s max [psig]	363		232		218	131	73	44	290	290
Stroke volume (can be set using handwheel)	[ml]	0 to 0.022		0 to 0.042		0 to 0.063		0 to 0.160		0 to 0.251	0 to 0.392
Stroke frequency (controlled externally)	[rpm]					0 to 185				0 to 130	0 to 130
Metering accuracy at constant basic conditions						+/- 0.5 to 1%				+/- 1%	+/- 1%

Material in contact with fluid	For material variants	Stainless steel	Hastelloy	Stainless steel	Stainless steel
Diaphragm body		316/316L	2.4610	316/316L	—
Diaphragm		1.4401 K	3.4610 K	1.4401K	—
Valve seats		Al ₂ O ₃	Al ₂ O ₃	316/316L	—
Valve balls		Ruby (Al ₂ O ₃)	Ruby (Al ₂ O ₃)	OK1	OK1
Valve seals		PTFE, filled	PTFE, filled	PTFE, filled	PTFE, filled
Valve springs (only as needed)		316/316L	2.4610	316/316L	—
Temperature limits	Fluid temperature	+50.0 to +176.0 °F		+50.0 to +176.0 °F	+50.0 to +176.0 °F
	Heating medium temperature	+212.0 °F max		+212.0 °F max	+212.0 °F max
	Sterilization temperature	+302.0 °F for 30 min		—	—
Connections	Suction/discharge side	ISO 228 G 1/8		ISO 228 G 3/8	ISO 228 G 3/8
	Heating/Cooling	ISO 228 G 1/8		ISO 228 G 1/8	ISO 228 G 1/8
Degree of protection		IP 55		IP 55	IP 55
Ex protection class		II 2G c IIC T1-T4		II 2G c IIC T1-T4	II 2G c IIC T1-T4
Dimensions	H x W x D [inch]	10.63 x 4.41 x 4.06		20.08 x 6.14 x 6.50	20.08 x 6.14 x 6.50
Weights	[lbs]	MAH 3 (Ex): 9; MAH 4 (Ex); MAH 5 (Ex): 10; MAH 8 (Ex): 10		44 - 49	44 - 49
Associated control system		Type MSG		—	—

Installation dimensions

	L in inch	W in inch	ΔW in inch	H in inch
MAH size 3	4.02	2.76	4.33	10.24
MAH size 4	4.02	3.15	4.72	10.24
MAH size 5	4.02	3.15	4.72	10.24
MAH size 8	4.02	3.15	4.72	10.24
MBH size 8 Ex	6.10	4.72	7.68	20.08
MBH size 10 Ex	6.10	4.72	7.68	20.08

MLM Ex technical data

Pump type			MLM 15 Ex	MLM 40 Ex
Head type			M210	M210
Material ^{*3}			3/3L/4	3/3L/4
Piston diameter [inch]	Adjustable stroke volume [ml]	Metered flow ^{*1} at max. 90 strokes/min Q_{theor} [l/h] / (gph)	Operating pressure $p_{\text{o,max}}$ [psig] ^{*2}	
0.12	0-0.106	0-0.57/(0-0.15)	3,070	8,120
0.20	0-0.294	0-1.59/(0-0.42)	1,100	2,970
0.31	0-0.754	0-4.07/(0-1.08)	435	1,160
0.39	0-1.18	0-6.36/(0-1.68)	276	740
0.47	0-1.70	0-9.16/(0-2.42)	189	508
0.63	0-3.02	0-16.3/(0-4.31)	109	290
0.79	0-4.71	0-25.4/(0-6.71)	—	189
0.98	0-7.36	0-39.7/(0-10.49)	—	119
1.18	0-10.6	0-55.0/(0-14.53)	—	83
Degree of protection			IP 55	
Ex protection class			II 2G c IIC T1-T4	II 2G c IIC T1-T4
H x W x D dimensions [inch]			9.06 x 11.42 x 12.83	9.06 x 11.42 x 15.51
Weights [lbs]			51 - 55	51 - 71

*1 Q_{theor} consisting of stroke volume x stroke frequency
 Q_{eff} is provided in the design data sheet

*2 Standard pump head connections:
 Internal thread in accordance with DIN or NPT
 On request: Flange in accordance with DIN, IG, ANSI or BS,
 dairy pipe fittings or other

*3 Available material variants:
 3 = CrNiMo 18/10/2 stainless steel
 3L = food-safe design
 4 = Hastelloy C
 Additional materials on request, such as tantalum, nickel, Hastelloy B, titanium

MLM 15 Ex and MLM 40 Ex installation dimensions

	L in inch	W in inch	H in inch
Size 3	17.72	5.51	10.24
Size 20	17.72	7.09	10.24

Control systems

Control system		MSG 60	Isolating switch unit	Thermistor triggering device
Connection value		230V AC/17 VA 115V AC/17 VA	20 - 250V UC/3W	24 - 240V UCw/2W
Control circuit	Digital input	Floating contact or optocoupler Infeed voltage: 8V DC Current load: 8 mA	Intrinsically safe for MLM proximity switch [Ex ia Ga] IIC [Ex ia Da] IIIC	Infeed for MLM40 thermistor [Ex] II (2) G [Ex] II (2) GD
	Analog input (12-bit resolution)	0/4 - 20 mA Input resistance: 125 ohms	TÜV 04 ATEX 2553	PTB 01 ATEX 3218
	MLM proximity switch	Infeed voltage: approx. 15V DC	Max. infeed voltage: 9.6V DC Max. infeed current: 11 mA	Max. infeed voltage: 2V DC Max. infeed current: 1 mA
	MLM40 PTC sensor			
Output	Power output for solenoid-driven pump	196V DC (at supply of 230V AC) 98V DC (at supply of 115V AC) 24V DC (at supply of 24V DC)	(internally for MSG 60)	(internally for MSG 60)
Temperature range		0 to +140.0 °F (non-condensing)	-4.0 to +158.0 °F (non-condensing)	-4.0 to +140.0 °F (non-condensing)
Design		3.94 x 6.30" Eurocard; 3 RU	4.09 x 0.71 x 4.33" attached enclosure	4.09 x 0.89 x 4.33" attached enclosure
Housing H x W x D	19" assembly rack 3 RU, 84 HP	5.22 x 19.02 x 9.45"	Installed into 19" assembly rack	Installed into 19" assembly rack
	Workbench housing	5.51 x 6.69 x 9.45"	—	—
	CC5000 wall housing	9.33 x 8.15 x 9.29"	Installed into CC5000 wall housing	—
	CC7000 wall housing	9.33 x 13.94 x 9.29"	Installed into CC7000 wall housing	Installed into CC7000 wall housing

FC series performance overview

Standard piston diameter [inch]	Q_{theor} [l/h]/(gph) *1 Theoretical metered flow for each pump head at maximum stroke length and stroke frequency n [rpm] *2				Type Type *4 Material *3	Permitted operating pressure of available standard pump heads p [psig of excess pressure] *5	
	n = 26	n = 52	n = 80	n = 160		Piston pump heads K 110/K 111 2, 3, 3L	Diaphragm pump heads M 213 3, 4
0.12	0.110 / (0.03)	0.220 / (0.06)	0.339 / (0.09)	0.678 / (0.09)		2,320	5,800
0.20	0.306 / (0.08)	0.612 / (0.16)	0.942 / (0.25)	1.885 / (0.50)		2,320	5,430
0.31	0.784 / (0.21)	1.568 / (0.41)	2.413 / (0.64)	4.825 / (1.27)		2,320	—
0.39	1.225 / (0.32)	2.450 / (0.65)	3.770 / (1.00)	7.540 / (1.99)		1,480	—
0.47	1.764 / (0.47)	3.528 / (0.93)	5.429 / (1.43)	10.86 / (2.87)		1,030	—
0.63	3.136 / (0.83)	6.27 / (1.66)	9.65 / (2.55)	19.30 / (5.10)		580	—
0.79	4.901 / (1.29)	9.80 / (2.59)	15.08 / (3.98)	30.16 / (7.97)		363	—
0.98	7.65 / (2.02)	15.31 / (4.04)	23.56 / (6.22)	47.12 / (6.22)		232	—
1.18	11.03 / (2.91)	22.05 / (5.82)	33.93 / (8.96)	67.86 / (17.93)		160	—

*1 Q_{theor} consisting of stroke volume x stroke frequency
 Q_{eff} is listed on the specification sheet
 For multiplex pumps, multiply the total metered flow by the number of pump heads to determine the value

*2 Stroke frequencies available at 50 Hz: n = 26, 43, 52, 80, 143, 160 rpm

*3 2 = 13% Cr steel; 3 = CrNiMo 18/10/2 stainless steel
 3L = food-safe design; 4 = Hastelloy C
 Additional materials on request, such as tantalum, nickel, titanium, Hastelloy B, PTFE carbon

*4 Standard pump head connections: Internal thread in accordance with DIN and NPT
 On request: Flange in accordance with DIN, ANSI or BS,
 dairy pipe fittings or other

*5 Permitted inlet pressure on request

Installation dimensions

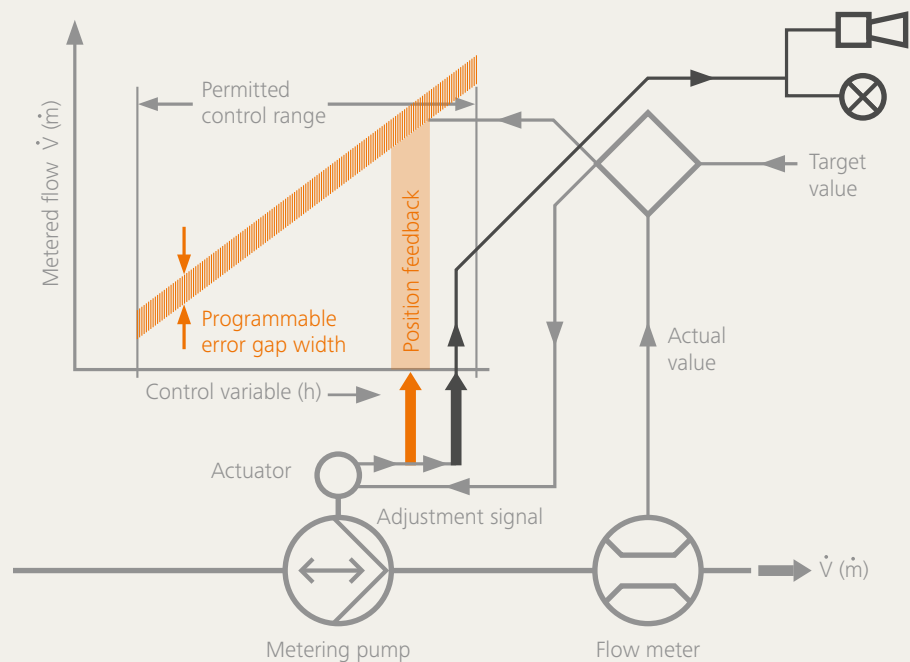
	L in inch	W in inch	ΔW in inch	H in inch
FC size 1	14.76	6.46	4.72	15.75
FC size 3	14.76	12.80	11.69	15.87

Integration into systems.

LEWA also offers solutions that go beyond individual micro-metering pumps.

We have been building customized metering systems for decades. Our service ranges from engineering to commissioning – including individualized system control, process display, production data acquisition and external interfacing to the process control system.

We guarantee optimal implementation of your requirements thanks to our knowledge and skills in smart process control and the control and regulation technology it requires. Professional input into the selection and combination of the system components and their features provide the foundation.



LEWA metering systems for laboratories and test centers offer you:

Design according to customer requirements

Safe LEWA micro-metering pumps with metal diaphragm free of leaks

With or without Ex protection

Long-term metering accuracy better than +/- 0.5%

Measurement of effective metered flow

Regulation of the metered flow in a closed control loop

Controller for LEWA smart control

Automatic stabilization of fluctuating operating conditions

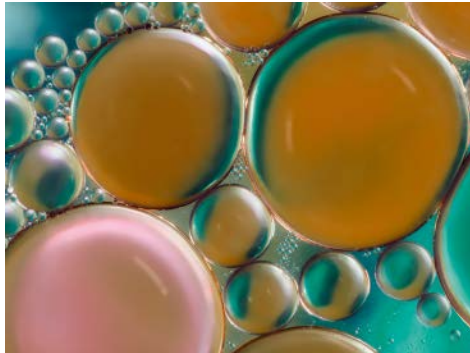
Automatic fault reporting

Integration into higher-level process control systems

Creating Fluid Solutions. For more value created.



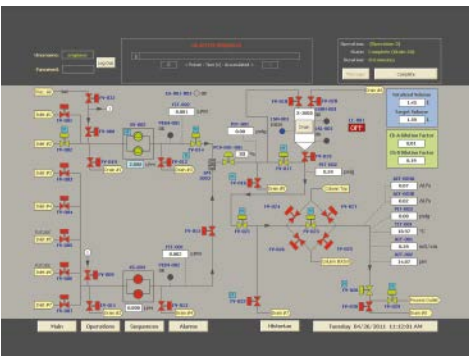
Technical consulting



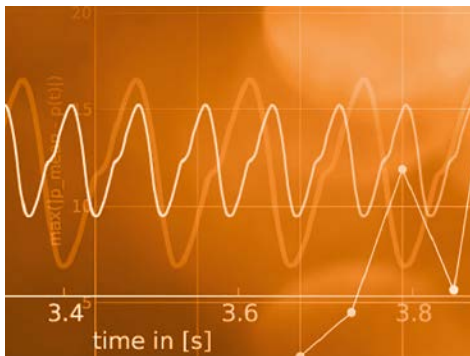
Fluid and process engineering tests



Lifecycle concepts and energy optimization



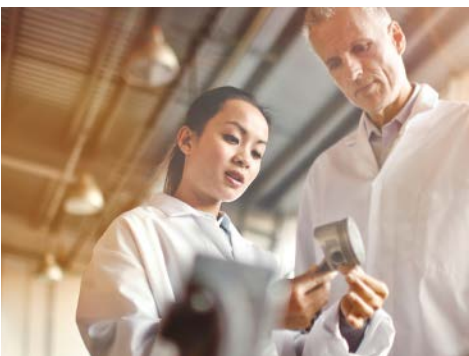
Process automation



Pulsation studies and pipeline calculations



System layout and integration



Creative development and refinements



Commissioning and maintenance service



Spare part and service concepts

Creating Fluid Solutions.

Driven by our commitment, our trendsetting products and innovative technologies have set benchmarks for diaphragm pumps and metering systems for over 70 years. We solve complex tasks from a single source. That ranges from custom pump design, basic and system engineering, global project management, and pretesting to commissioning and maintenance on site. Our consistent drive always to develop the best solutions for the customer provides you with a competitive advantage and visible added value.

LEWA-Nikkiso America, Inc.

132 Hopping Brook Road
Holliston, MA 01746, USA
Phone: +1 508 429-7403
Fax: +1 508 429-8615

LEWA-Nikkiso America, Inc.

Gulf Coast Sales & Service Center
2446 Greens Road
Houston, TX 77032, USA
Phone: +1 713 577-5392
Fax: +1 713 577-5393

sales@lewa-inc.com
www.lewa-inc.com

Your local representative:

